INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 13, 2026

IGI Report Number	LG817680294
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MIXED CUT
Measurements	10.11 X 6.47 X 4.40 MM

GRADING RESULTS

Carat Weight	2.80 CARATS
Color Grade	E
Clarity Grade	VVS 2

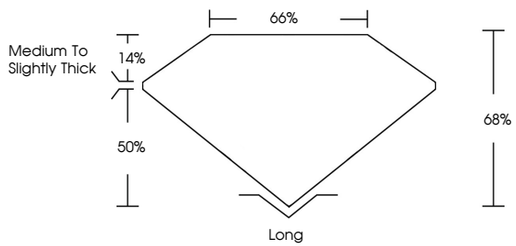
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG817680294

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG817680294
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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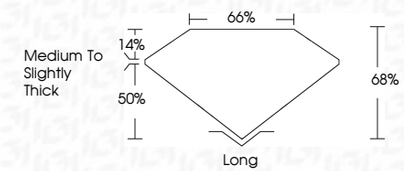

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CUT CORNERED RECT. MIXED CUT
10.11 X 6.47 X 4.40 MM

Carat Weight	2.80 CARATS
Color Grade	E
Clarity Grade	VVS 2
Depth	68%
Table	65%
Girdle	Medium To Slightly Thick
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG817680294

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